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PATENT  
81839.0142

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Eiichi IINO, et al.

Serial No: 10/695,609

Filed: October 28, 2003

For: SILICON SEED CRYSTAL AND  
METHOD FOR PRODUCING  
SILICON SINGLE CRYSTAL

Art Unit: 1722

Examiner: M. A. Anderson

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PETITION FOR EXTENSION OF TIME

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Dear Sir:

I hereby certify that this paper and every paper referred to herein is being transmitted via facsimile to recipient at (571) 273-8300 on:	
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In accordance with 37 C.F.R. 1.136, Applicant respectfully petitions the Commissioner for a two-month extension of time extending to September 19, 2006, the period for response to the Advisory Action dated August 2, 2006. Please charge the fee of \$450 for this extension to Deposit Account No. 50-1314. The responsive paper(s) are attached.

Please charge any insufficiency or credit any overpayment to Deposit Account No. 50-1314. A copy of this petition is enclosed.

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01 FC:1252 450.00 DA

Respectfully submitted,

HOGAN & HARTSON L.L.P.

By:

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